

# Enhancing oxygen reduction reaction of $YSZ/La2NiO4+\delta$ using an ultrathin $La2NiO4+\delta$ interfacial layer

Messaoud Benamira, Armelle Ringuedé, Michel Cassir, David Horwat, Pascal Lenormand, Florence Ansart, Jean-Marc. Bassat, Jean-Paul Viricelle

## ▶ To cite this version:

Messaoud Benamira, Armelle Ringuedé, Michel Cassir, David Horwat, Pascal Lenormand, et al.. Enhancing oxygen reduction reaction of YSZ/La2NiO4+ $\delta$  using an ultrathin La2NiO4+ $\delta$  interfacial layer. Journal of Alloys and Compounds, 2018, 746, pp.413-420. 10.1016/j.jallcom.2018.02.339 . hal-01744173

# HAL Id: hal-01744173 https://hal.science/hal-01744173

Submitted on 21 Oct 2019

**HAL** is a multi-disciplinary open access archive for the deposit and dissemination of scientific research documents, whether they are published or not. The documents may come from teaching and research institutions in France or abroad, or from public or private research centers.

L'archive ouverte pluridisciplinaire **HAL**, est destinée au dépôt et à la diffusion de documents scientifiques de niveau recherche, publiés ou non, émanant des établissements d'enseignement et de recherche français ou étrangers, des laboratoires publics ou privés.



# Open Archive Toulouse Archive Ouverte (OATAO)

OATAO is an open access repository that collects the work of Toulouse researchers and makes it freely available over the web where possible

This is an author's version published in: <u>http://oatao.univ-toulouse.fr/24536</u>

Official URL: https://doi.org/10.1016/j.jallcom.2018.02.339

### To cite this version:

Benamira, Messaoud and Ringuede, Armelle and Cassir, Michel and Horwat, David and Lenormand, Pascal and Ansart, Florence and Bassat, Jean-Marc and Viricelle, Jean-Paul *Enhancing oxygen reduction reaction of YSZ/La2NiO4+* $\delta$  using an ultrathin La2NiO4+ $\delta$  interfacial layer. (2018) Journal of Alloys and Compounds, 746. 413-420. ISSN 0925-8388

Any correspondence concerning this service should be sent to the repository administrator: <u>tech-oatao@listes-diff.inp-toulouse.fr</u>

# Enhancing oxygen reduction reaction of $YSZ/La_2NiO_{4+\delta}$ using an ultrathin $La_2NiO_{4+\delta}$ interfacial layer

M. Benamira <sup>a, b, \*</sup>, A. Ringuedé <sup>b</sup>, M. Cassir <sup>b</sup>, D. Horwat <sup>c</sup>, P. Lenormand <sup>d</sup>, F. Ansart <sup>d</sup>, J.M. Bassat <sup>e</sup>, J.P. Viricelle <sup>f</sup>

<sup>a</sup> Laboratory of Interaction Materials and Enviranment (LIME), University of Mohamed Seddik Ben Yahia, 18000, Jijel, Algeria

<sup>b</sup> PSL Research University, Chimie Paristech-CNRS, Institut de Recherche de Chimie de Paris, 11 rue Pierre et Marie Curie, F-75231, Paris Cedex 05, France

<sup>c</sup> Institut Jean Lamour, UMR7198, Université de Lorraine, 54011, Nancy, France

<sup>e</sup> ONRS, IOMCB, 87 avenue du Dr. A. Schweitzer, F-33608, Pessac, France

<sup>f</sup> Ecole Nationale Supérieure des Mines, SPIN-EMSE, CNRS: UMR5307, LGF, 42023, Saint-Etienne, France

ARTICLE INFO

Keywords: SOFCs La2NiO4+8 cathode Ultrathin film Sputtering Dip-coating

#### ABSTRACT

In this work,  $La_2NiO_{4+\delta}$  is used as cathode material for Intermediate temperature solid oxide fiel cells (IT SOFC). Scanning electron microscopy, X ray diffraction, and electrochemical impedance spectroscopy are used to investigate the effect of the presence of an ultrathin  $La_2NiO_{4+\delta}$  layer (80 nm) deposited by dip coating or sputtering at the interface YSZ/La<sub>2</sub>NiO<sub>4+δ</sub>. The thick porous cathode layer of  $La_2NiO_{4+\delta}$  is deposited by screen printing, and sintered at 1000 °C for 2 h or 1200 °C for 20 min in order to study the effect of sintering temperature on the electrochemical properties. The results show that the electrochemical properties are obtained with the use of the nano film interface layer deposited by sputtering. The introduction of ultrathin interface with nano grained between the cathode and electrolyte is a promising technique to reduce polarization resistance associated with oxygen reduction reaction (ORR) on the cathode.

#### 1. Introduction

Solid oxide Fuel cell (SOFC) is a device where the chemical energy is converted to electrical energy. The most important chal lenge in SOFCs development is the reduction of the working temperature from 800 1000°C to 500-700°C which reduces manufacturing costs, owing to use of inexpensive materials, such as stainless steels for interconnects and decreases materials degra dation. However, decreasing the temperature leads an increase in the ionic conductivity of the solid electrolyte and in the polariza tion resistance of the electrodes, in particularly at the cathode side. The ohmic loss is usually decreased by the reduction of the conventional electrolyte thickness, yttria stabilised zirconia (YSZ), or by finding a new material exhibiting a high ionic conductivity [1–5]. For the electrode, the high cathode polarization may be

• Corresponding author. Laboratory of Interaction Materials and Environment (IJME), University of Mohamed Seddik Ben Yahia, 18000, Jijel, Algeria.

E-mail address; m\_benamira@univ-jijel.dz (M. Benamira).

reduced by improving the microstructure at the interface electro lyle/cathode and/or a development of new cathode materials with high electrochemical activity as the mixed ionic and electronic conductors (MIECs) [6–9].

Recently, the family of compounds  $A_2MO_{4+\delta}$  with the K<sub>2</sub>NiF<sub>4</sub> type structure has attracted more attention as alternative cathode materials for intermediate temperature SOFCs (IT SOFCs) [8,9] due to their high electronic conductivity, thermal expansion coefficients (TECs) close to the solid electrolyte, high electrocatalytic activity, and some oxygen overstoichiometry which enhances the oxygen ionic conduction [10–13]. Among those materials, La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> has shown a wide range of oxygen overstoichiometry and presents one of the highest oxygen diffusion values [14]. The structure of La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> is built of alternative rock salt La<sub>2</sub>O<sub>2</sub> and perovskite NiO<sub>2</sub> layers, and can contain a significant oxygen excess [14–17]. The ionic transport takes place through diffusion phenomena of inter stitial ions in the vacancies in the perovskite layers and the rock salt layer [8,18].

Development of new architecture of SOFCs has been extensively investigated. It is reported that the electrode performance can be

<sup>&</sup>lt;sup>d</sup> CIRIMAT/LCMIE/UMR5085, Université Paul Sabatier, bât IIR1, 118, route de Naıbonne, 31062, Toulouse Cedex 04, France

improved by using an interlayer thin film with fine microstructure at the interface electrolyte/electrode and covered by a thick and porous layer with large grain sizes [19–22]. The fine electrode microstructure close to the electrolyte increases the reaction zone by the enlargement of the triple phase boundary (TPB), the elec trochemical active surface area and improved oxygen reduction reaction (ORR) kinetics [15,23].

The present work is focused on the optimisation of thick layer of La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> obtained by screen printing to analyse their structural and electrochemical performance and compare them in a new configuration with ultrathin layer (80 nm) of La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> deposited at the interface YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> by dip coating or sputtering, developed in two laboratories, <sup>d</sup>CIRIMAT and <sup>c</sup>LSGS, respectively. The electrochemical performances of all the samples were realised in the same entity, <sup>b</sup>IRCP.

#### 2. Experimental

#### 2.1. Preparation of electrolyte substrates

The electrolyte substrates are prepared from an YSZ commercial powder containing 8 mol% of  $Y_2O_3$  (TZ8Y from Tosoh Corp, Japan). The powder is pressed into pellets of 19 mm diameter and sintered at 1350 °C for 2 h in air. The density of the samples is up to 95%.

YSZ Pellets are mirror polished with an average roughness of about 10–15 nm and cleaned in ultrasonic baths of acetone and then in ethanol using an ultrasonic bath.

# 2.2. Preparation of precursor and deposition of $La_2NiO_{4+\delta}$ ultrathin film with dip coating or sputtering

The Lanthanum nickelates ultrathin films (80 nm) were sputter deposited on glass slides and YSZ substrates by co sputtering of La and Ni metallic targets in the presence of a reactive argon-oxygen gas mixture. The experimental device is a 40 L sputtering chamber pumped down via an oil diffusion suction system allowing a base vacuum of about  $10^{-4}$ Pa, equipped with two targets separated by 100 mm with a rotating substrate holder positioned parallel to the target surfaces as shown in Ref. [24]. In addition, the target to substrate distance was set to 50 mm for the La target and to 80 mm for the Ni target. The substrate was positioned at 50 mm from the center of the substrate holder. The La targets, 50 mm in diameter, are mounted on unbalanced magnetrons and were powered by Advanced Energy generators. The Ni target was powered using an advanced energy direct current MDX 1.5 K generator and the La target was powered using an advanced energy pulsed DC Pinnacle +5 kW generator. The argon and oxygen flow rates were set to 30 sccm for argon and 10 sccm for oxygen and resulted in a working pressure of 0.5 Pa. The discharge current applied to the La and Ni targets were 1 A and 0.1 A for the La and Ni target, respec tively. These conditions allowed obtained a La/Ni ratio of atomic concentrations of 2 as shown in a previous study conducted on the same deposition chamber [24]. Coating thickness is determined by the step method with a Talysurf profilometer.

On the other hand, the sol employed for the ultrathin layer deposited by dip coating corresponding to  $La_2NiO_{4+\delta}$  phase is prepared by using a polymeric route similar to this outlined by Pechini [25]. Pure metal nitrates,  $La(NO_3) \cdot 6H_2O$  and  $Ni(NO_3)_2 \cdot 6H_2O$  are used as starting salts. They are dissolved in water in stoichiometric amounts [26]. The solution was mixed to an organic solution of hexamethylenetetramine and acetyl acetone with a molar ratio (1:1), in acetic acid. Therefore, a range of molar ratio of complexing agent to nitrate species (called *R*) has been defined. Pure phase is obtained for *R* ratio ranging from 2 to 3. The resulting solution was then stirred and heated in air at 70 °C until

sols. Lanthanum nickelates ultrathin layers are, dip coated on polished mirror Yttria Stabilised Zirconia (YSZ) polycrystalline substrates. The optimal heat treatment to fire the samples is 1000 °C during 2 h in air with a heating rate of 100 °C/h in order to get a well determined oxides structure [26].

#### 2.3. Deposition of $La_2NiO_{4+\delta}$ thick cathode by screen printing

The La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> oxides are prepared using the solid state reac tion. A stoichiometric mixture of rare earth oxide (La<sub>2</sub>O<sub>3</sub>, Strem, 99.99%) and nickel oxide (NiO, Aldrich, 99.9%) is annealed at 1300 °C and grounded using a milling attritor. After this treatment, the obtained average particle size is around 1 µm.

The screen printing ink is prepared using a La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> powder mixed with a commercial organic binder (PVB). A solvent is added to obtain adequate ink viscosity (X g of powder with 85% X g of solvent (terpineol) + 4% X g of dispersant (Dolapix) + 14% X g of binder). Ink is deposited on YSZ pellet. The layer is then dried at 120 °C and annealed at 1000 °C for 2 h or 1200 °C for 20 min with a temperature rising rate of 15 °C/min. The whole electrode thickness is about 10–15 µm.

#### 2.4. Microstructural and electrical analysis

Different techniques are used to characterise the YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> samples. Crystallinity is determined by X ray diffraction (XRD), the microstructure and the thickness of the samples are investigated using scanning electron microscope (SEM) and the electrical properties are analysed by impedance spectroscopy.

The surface morphology and the microstructure of the cross section of the samples are investigated using scanning electron microscope SEM (S440, FEG). The thickness of the deposits is determined from cross sectional SEM micrographs. X ray diffrac tion analysis is determined using a Co K<sub>α</sub> radiation ( $\lambda$  1.78897 Å) with 20 varying from 25 to 73°. The diffraction pattern is scanned by steps of 0.02° with 2 s counting times.

Electrical measurements are performed by impedance spec troscopy, using a PGSTAT 20 potentiostat, Autolab Ecochemie BV (Amsterdam, Netherlands). Impedance spectroscopy measure ments are carried out under ambient atmospheric air as a function of the temperature. A specific two electrode asymmetric configu ration is used [27]. With respect to the system linearity, 50 mV ac signal amplitude is applied, without DC polarization. Each imped ance measurement is carried out in the 1 MHz–10 mHz frequency range, with 11 points per decade. The temperatures vary from 390 °C to 700 °C. The numbers show in the impedance diagrams indicates the logarithm of the measuring frequency. The impedance data is deconvoluted by the software EQUIVCRT [28].

#### 3. Results and discussion

The X ray diffraction patterns at room temperature for La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> thick layer deposited by screen printing onto YSZ sub strate and annealed at 1000 °C for 2 h or 1200 °C for 20 min are shown in Fig. 1. There is no significant reaction between the La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> cathode and the electrolyte when the sample is sintered at 1000 °C for 2 h (Fig. 1a). The peaks corresponding to the pure and well crystallized K<sub>2</sub>NiO<sub>4</sub> structure (JCPDS, ref. 72 1241) can be observed. However, there is a slight reaction when the La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> cathode is screen printed onto YSZ and sintered at 1200 °C for 20 min, leading to the formation of impurity phase as shown in (Fig. 1b). According to the literature [29,30], La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> can be decomposed to produce higher order Ruddlesden Popper (La<sub>n+1</sub>Ni<sub>n</sub>O<sub>3n+1</sub> where n 2 or 3) and La<sub>2</sub>O<sub>3</sub> at higher tempera ture ( $\geq$ 1150 °C). Gauquelin et al. confirm the presence of La<sub>3</sub>Ni<sub>2</sub>O<sub>7</sub>

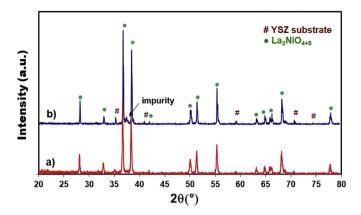


Fig. 1. X-ray diffraction pattern of La<sub>2</sub>NiO<sub>4+ $\delta}$ </sub> cathode deposited by screen-printing and annealed at a) 1000 °C/2 h and b) 1200 °C/20 min.

and La<sub>4</sub>Ni<sub>3</sub>O<sub>10</sub> using transmission electron microscopy (TEM) after a long term decomposition experiment of La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> at 1000 °C in flowing air for two weeks [31]. This result is also partly confirmed by the theoretical study using density functional theory (DFT) [29]. It should be noted that the formation of La<sub>n+1</sub>Ni<sub>n</sub>O<sub>3n+1</sub> (n 2 and 3) phases present a beneficial effect with high electrical transport properties (high electronic conductivity) [32–34]. No decomposi tion of La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> or chemical reaction with YSZ were found at 1000 °C. Nevertheless, reactivity or decomposition were observed at 1200 °C according to DRX (Fig. 1).

The sintering temperature dramatically affects the microstruc ture of the electrode. Fig. 2 shows the SEM micrographs for La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> films sintered at 1000 °C and 1200 °C. It can be seen that fine rand smaller particles can be obtained when the sintered temperature decreased (1000 °C). The sample sintered at 1200 °C

possesses low porosity and inhomogeneous pore size distribution. The comparison of the figures of the two samples illustrates the coarsening of the La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> microstructure that occurs with the annealing. Larger particle sizes decrease not only the porosity but also the TPB and limits the gas transport in the gas phase to the electrode, leading to the decrease in electrochemical reaction area.

The cross section SEM micrographs of the two samples are shown in Fig. 3. It can be seen that the  $La_2NiO_{4+\delta}$  cathode and the YSZ electrolyte attached well. Indeed, it is clearly shown the high densification of the electrolyte and the porosity of the cathode film. The thickness of the cathode for the two samples is around 13–15 µm (Fig. 3a, c). Homogeneous distribution of particles and pores is shown throughout the whole electrode thickness, partic ularly in the sample sintered at 1000 °C (Fig. 3a). The difference in the particles sizes and porosity between the two samples is well observed. Large and coarse particles are obtained after 1200 °C anneal of 20 min. The interface between the  $\text{La}_2\text{NiO}_{4+\delta}$  cathode and the YSZ electrolyte are shown in more detail in Fig. 3b, d. It can be observed the presence of a new phase with small particles at the interface YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> for the sample sintered at 1200 °C (Fig. 3d), which confirms the impurity phase observed in the X ray diffrac tion (Fig. 1b). However, no significant reaction between the  $\text{La}_2\text{NiO}_{4+\delta}$  cathode and the electrolyte is observed when the sample is sintered at 1000 °C (Fig. 3b).

Fig. 4 shows the Arrhenius plots of the polarization resistance of the two samples with La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> thick screen printed layer and annealed at 1000 °C and 1200 °C. For the thick cathode layer deposited onto YSZ, the lowest polarization resistances are found for the La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> sintered at 1000 °C. The decrease of performance of sample sintered at 1200 °C can be attributed to the degradation of the interface YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> with the formation of ion blocking phase at the interface as it can be seen in the X ray diffraction and SEM micrograph of Figs. 1 and 3. In order to confirm this result, tow simples of YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> with an ultrathin interfacial layer

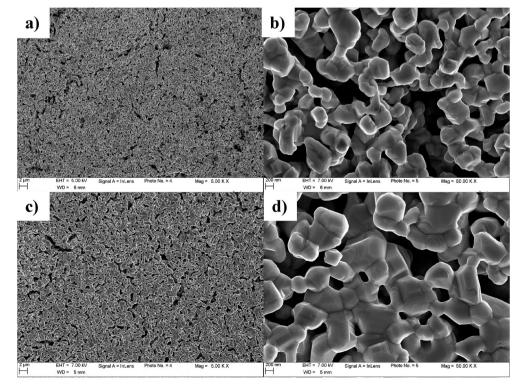


Fig. 2. SEM micrographs of surface morphology of  $La_2NiO_{4+\delta}$  thick layer deposited by screen-printing onto YSZ electrolyte and annealed at a, b) 1000 °C/2 h and c, d) 1200 °C/2 o min.

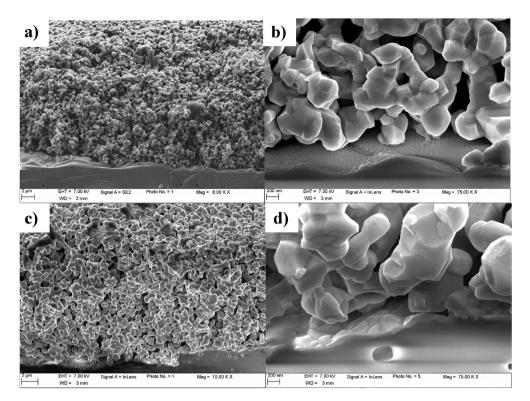
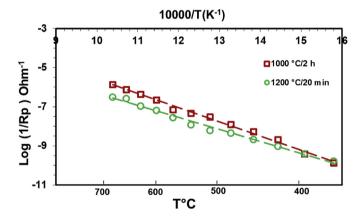


Fig. 3. SEM micrographs of cross-section of La<sub>2</sub>NiO<sub>4+δ</sub> thick layer deposited by screen-printing onto YSZ electrolyte and annealed at a, b) 1000 °C/2 h and c, d) 1200 °C/20 min.



**Fig. 4.** Arrhenius plots of the polarization resistance for  $La_2NiO_{4+\delta}$  cathode deposited by screen-printing onto YSZ electrolyte and annealed at:  $\Box$ ) 1000 °C/2 h, O) 1200 °C/20 min.

deposited by dip coating are prepared and annealed at 1000 °C for 2 h and 1200 °C for 20 min. Fig. 5 shows SEM micrographs of the surface morphology and the cross section of the fractured surface of the ultrathin films deposited at the interface YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> by dip coating onto YSZ substrate. After annealing of the ultrathin films at 1000 °C for 2 h, the SEM micrographs show that the fired film exhibits small pores as well as small solid phase islands. The microstructure presents a homogeneous distribution of the islands sizes and is very fine. The particle sizes in the ultrathin layer are clearly much smaller than those deposited by screen printing, and the surface appears denser. The X ray diffraction (XRD) patterns at room temperature for La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> ultrathin layer deposited by dip coating and recovered by a thick layer and annealed at 1000 °C for 2 h and 1200 °C for 20 min are shown in Fig. 6.

The X ray diffraction analysis reveals that the cathode has a pure and well crystallized K<sub>2</sub>NiO<sub>4</sub> structure. The peaks corresponding to the YSZ substrate can be observed. For the YSZ/LSM (dip coating) sample (Fig. 6a), the intensity of the lines corresponding to the  $La_2NiO_{4+\delta}$  phase is very low compared to the YSZ substrate, which is due to the  $La_2NiO_{4+\delta}$  ultra thin layer (80 nm) deposited by dip coating. The cathode peaks become well defined when a thick La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> layer is deposited as it can be seen in the two other samples (Fig. 6b, c). The typical impedance spectra obtained at 600 °C by impedance spectroscopy of the two samples with inter facial layer of  $La_2NiO_{4+\delta}$  and annealed at 1000 °C and 1200 °C are presented in Fig. 7 a. In general, the spectra measured presents two contributions. The first contribution, in the high frequency range, is smaller (up to 100 KHz), whereas, the second contribution, attrib uted to the electrode responses, at medium and low frequencies are predominant and well defined in the frequency range used. The impedance diagrams of Fig. 7 a show that the two samples have the same responses at high frequency (HF) which is attributed to grain and grain boundary resistances of YSZ electrolyte [27]. The two other arcs are assigned to the phenomena occurring at the elec trode and electrode/electrolyte interface. This indicates that the O<sub>2</sub> reduction on the La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> cathode is controlled by at least two different processes. The associated equivalent circuit used to fit the experimental data is shown in Fig. 7 b, in which each arc is adjusted to R CPE elements in parallel. The appearance of the arcs in the impedance diagrams are related to the rate determining steps in the oxygen reduction on the  $\text{La}_2\text{NiO}_{4+\delta}$  electrode. The medium frequency contribution is assigned to oxygen ion transfer across the electrode/electrolyte interface and charge transfer process, and the low frequency contribution is related to molecular oxygen disso ciation, oxygen diffusion through the electrode layer and adsorp tion phenomena on the porous La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> surface [35–38].

The low electrode polarization resistance is obtained when the sample is sintered at 1000  $^{\circ}$ C for 2 h as it can be seen in Fig. 8. This

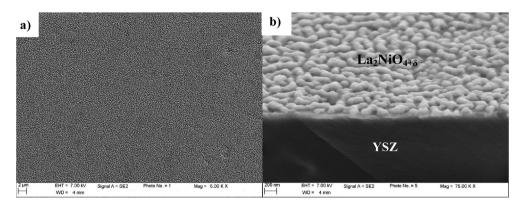
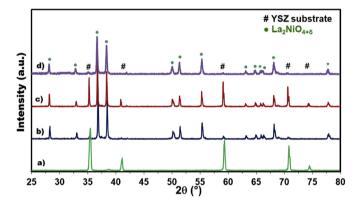


Fig. 5. SEM micrographs of La<sub>2</sub>NiO<sub>4+δ</sub> thin layer deposited by dip-coating onto YSZ electrolyte and annealed at 1000 °C/2 h, a) surface morphology and b) cross-section.



**Fig. 6.** X-ray diffraction patterns of a) YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> (dip-coating), YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> (dip-coating)/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> (screen-printing) annealed at b) 1000 °C/2 h and c) 1200 °C/20 min, d) YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> (sputtering)/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> (screen-printing).

result can be explained by the relationship between the sintering process of the  $La_2NiO_{4+\delta}$  and the grains growth with their subse quent coalescence. Fig. 9 illustrates the difference between the ef fects of 1000 and 1200 °C temperature sintering on sample microstructure. The SEM micrographs show microstructural changes that can explain the observed result. The thick cathode layers sintered at 1000 °C for 2 h presents a porous and homoge nous structure, the particles are well connected and the smaller particles coalesced to form larger aggregates (Fig. 9a). The cathode particle sizes are around 0.2–0.3 µm. The particle sizes are less homogeneous; it can be seen small grains size less than 0.1 µm attached to larger grains  $(0.4 \,\mu m)$ . The porosity distribution of the cathode in Fig. 9 b appears less homogeneous than that in Fig. 9 a and the porosity is smaller, due to 200 °C higher sintering tem perature. As a result, the good electrochemical performance of the cathode sintered at 1000 °C can be attributed to this difference in the microstructure. This temperature is used to sinter the sample

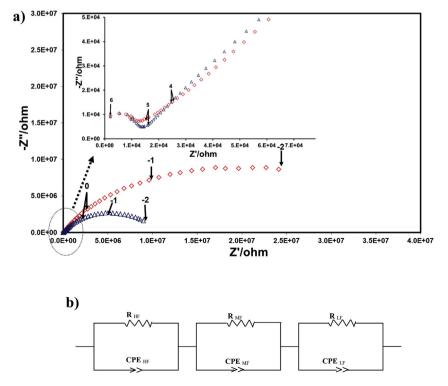
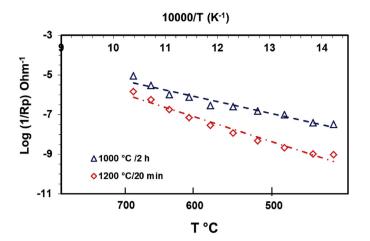


Fig. 7. a) Impedance diagrams measured at 600 °C under air, 50 mV for YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub>(dip-coating)/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> (screen-printing) samples annealed at  $\Delta$ ) 1000 °C/2 h and  $\delta$ ) 1200 °C/2 0 min b) Equivalent circuit used for fitting the experimental data.

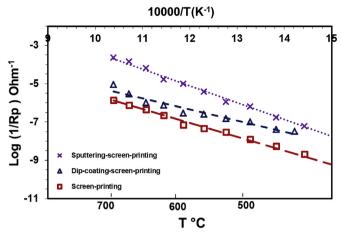


**Fig. 8.** Arrhenius plots of the polarization resistance for YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub>(dip-coating)/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> (screen-printing) samples annealed at  $\Delta$ ) 1000 °C/2 h and  $\Diamond$ ) 1200 °C/20 min.

with the La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> ultrathin interlayer deposited by sputtering. The X ray diffraction of the sample with sputtered ultrathin layer presented in Fig. 6d confirm the presence of a pure and well crystallized K<sub>2</sub>NiO<sub>4</sub> structure.

Fig. 10 shows clearly that the polarization resistance (Rp) of the sample with an ultrathin interlayer deposited by sputtering is smaller than that observed of the sample with an interlayer deposited by dip coating and sintered at the same temperature, 1000 °C/2 h. The Rp of cathode decreases by around two orders of magnitude. The significant improvement achieved with a thin  $La_2NiO_{4+\delta}$  compact layer between the dense electrolyte and porous electrode is a result of contact at the interface  $YSZ/La_2NiO_{4+\delta}$ enhancing the oxygen ion transfer to the electrolyte. In the tem perature range studied here, it is clear that the addition of the compact ultrathin interlayer deposited by dip coating or sputtering reduces the resistances assigned to the electrode processes compared to the electrode/electrolyte without interfacial laver (Fig. 10). The calculated ASR of the best sample with the dense sputtered ultrathin layer at 700 °C is given in Table 1 and compared to those values obtained by other authors with symmetrical cell configurations. The lowest ASR is observed with the presence of a compact layer at the interface electrolyte/cathode. This value is approximately 2 times less than the ASR reported by Zhao et al. [39].

The best performances of sample with interlayer deposited by sputtering can be attributed to the microstructure. Fig. 11 shows the



**Fig. 10.** Arrhenius plots of the polarization resistance of: x) YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub>(sputtering)/ La<sub>2</sub>NiO<sub>4+ $\delta$ </sub>(screen-printing)  $\Delta$ ) YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub>(dip-coating)/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub>(screen-printing) and  $\Box$ ) YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub>(screen-printing) samples annealed at 1000 °C/2 h.

SEM micrographs of the surface of  $La_2NiO_{4+\delta}$  cathode deposited onto the ultrathin sputtered laver and the cross section of the fractured surface of the two samples with ultrathin film layers deposited by sputtering or dip coating between the YSZ substrate and the  $La_2NiO_{4+\delta}$  thick film. The thick cathode layers deposited onto ultrathin sputtered layer (Fig. 11a, b) presents a porous and homogenous structure, the particles are well connected. The cathode particle sizes are around 0.1-0.3 µm. A slight decrease of the particle sizes is obtained in comparison to that observed with cathode deposited onto dip coating ultrathin layer (Fig. 7a). The thickness of the La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> thin film is about 55–75 nm for the two samples (Fig. 11c, d). It can be observed that the thin layers of  $La_2NiO_{4+\delta}$  cathode are well bonded to the electrolyte and there is clear difference between the thin  $La_2NiO_{4+\delta}$  cathode interlayer and the external thick  $La_2NiO_{4+\delta}$  cathode layer deposited by screen printing. The microstructures of the thin layers appear dense and

Table 1

Summary of ASR of La\_NiO\_4 electrode determined by Electrochemical Impedance Spectroscopy at 700  $^\circ\text{C}.$ 

| Reference             | Cell configuration                      | Cathode ASR at 700 $^\circ\text{C}(\Omega.\ \text{cm}^2)$ |
|-----------------------|---|---|
| This work             | La <sub>2</sub> NiO <sub>4</sub> on YSZ | 2.1   |
| Zhao et al. [39]      | La <sub>2</sub> NiO <sub>4</sub> on YSZ | 4   |
| Escudero et al. [37]  | La <sub>2</sub> NiO <sub>4</sub> on YSZ | 13.18   |
| Hernández et al. [30] | La <sub>2</sub> NiO <sub>4</sub> on YSZ | 17.7  |
| Sayers et al. [38]    | La <sub>2</sub> NiO <sub>4</sub> on CGO | 7.4   |

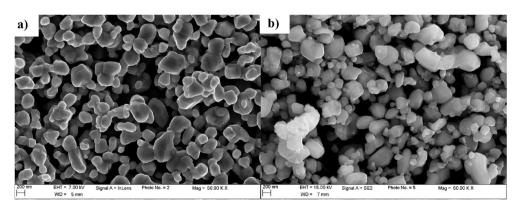
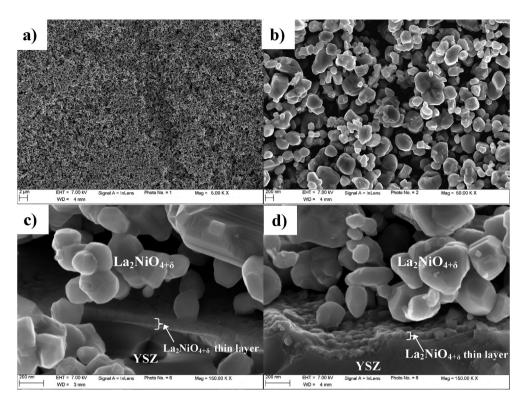


Fig. 9. SEM micrographs of surface morphology of YSZ/La<sub>2</sub>NiO<sub>4+δ</sub> (dip-coating)/La<sub>2</sub>NiO<sub>4+δ</sub> (screen-printing) samples annealed at a) 1000 °C/2 h and b) 1200 °C/20 min.



**Fig. 11.** a, b) SEM micrographs of surface morphology of  $La_2NiO_{4+\delta}$  cathode deposited by screen-printing onto thin sputtered layer, c) cross-section micrograph of YSZ/La<sub>2</sub>NiO<sub>4+\delta</sub> (sputtering)/La<sub>2</sub>NiO<sub>4+\delta</sub> (screen-printing) sample and d) cross-section micrograph of YSZ/La<sub>2</sub>NiO<sub>4+\delta</sub> (dip-coating)/La<sub>2</sub>NiO<sub>4+\delta</sub> (screen-printing) sample.

lack of porosity. The ultrathin layers are composed of small particles with a good adherence to the YSZ substrates. Furthermore, the particle sizes and the porosity of the ultrathin film at the interface in Fig. 11 c are smaller than those of Fig. 11d.

It is well known that fine porosity and fine electrode micro structure are desirable for the interface between the electrolyte and cathode to facilitate the charge transfer reaction. The dense cathode film can decrease the triple phase boundary at the interface, limit gas access and charge transfer reaction leading to Rp increase. This phenomenon is observed in Fig. 11 c and can explain the less electrochemical performance compared to the sample with the sputtered ultrathin film. The fine electrode microstructure close to the electrolyte, in this case the ultrathin layer deposited by sput tering, would significantly increases the cathode performance.

#### 4. Conclusion

This work is focused on a study of the influence of the use of an ultrathin layer of La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> at the interface electrolyte/cathode for SOFC operates at intermediate temperature. SEM micrographs show clearly that the annealing temperature has substantial modifications at the porous La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> cathode and the interface YSZ/La<sub>2</sub>NiO<sub>4+ $\delta$ </sub>. The porous electrode sintered at 1200 °C/20 min degrades faster than the sintered at 1000 °C/2 h due to the morphological effects of grain growth and their coalescence, interdiffusion across the electrolyte/cathode interface. Electrochemical impedance spectroscopy demonstrates that the presence of ultra thin sputtered La<sub>2</sub>NiO<sub>4+ $\delta$ </sub> interlayer with fine microstructure and porosity at the interface between yttria stabilised zirconia electrolyte and thick layer deposited by screen printing improves the electrochemical performance.

#### Acknowledgments

This work was financed within the frame of the French CNRS (National Research Center for Scientific Research) programs (ACI MICROSOFC).

#### References

- K. Venkataramana, C. Madhuri, Y.S. Reddy, G. Bhikshamaiah, C.V. Reddy, Structural, electrical and thermal expansion studies of tri-doped ceria electrolyte materials for IT-SOFCs, J. Alloys. Compd. 719 (2017) 97 107.
- [2] I. Khan, M.I. Asghar, P.D. Lund, S. Basu, I. Khan, M.I. Asghar, P.D. Lund, S. Basu, High conductive (LiNaK)2CO3Ce0.85Sm0.1502 electrolyte compositions for IT-SOFC applications, Int. J. Hydrogen Energy 42 (2017) (2017) 20904 20909.
- [3] M. Benamira, A. Ringuedé, L. Hildebrandt, C. Lagergren, R.N. Vannier, M. Cassir, Gadolinia-doped ceria mixed with alkali carbonates for SOFC applications: II an electrochemical insight, Int. J. Hydrogen Energy 37 (24) (2012) 19371 19379.
- [4] M. Benamira, A. Ringuedé, V. Albin, R.N. Vannier, L. Hildebrandt, C. Lagergren, M. Cassir, Gadolinia-doped ceria mixed with alkali carbonates for solid oxide fuel cell applications: I. A thermal, structural and morphological insight, J. Power Sources 196 (13) (2011) 5546 5554.
- [5] N. Preux, A. Rolle, C. Merlin, M. Benamira, M. Malys, C. Estournes, A. Rubbens, R.-N. Vannier, La3TaO7 derivatives with Weberite structure type: possible electrolytes for solid oxide fuel cells and high temperature electrolysers, Compt. Rendus Chem. 13 (2010) 1351 1358.
- [6] S.J. Skinner, J.A. Kilner, Oxygen diffusion and surface exchange in La 2- x Sr x NiO 4+ δ, Solid State Ionics 135 (1) (2000) 709 712.
- [7] C. Lalanne, F. Mauvy, E. Siebert, M.L. Fontaine, J.M. Bassat, F. Ansart, P. Stevens, J.C. Grenier, Intermediate temperature SOFC single cell test using Nd 1.95 NiO  $4+\delta$  as cathode, J. Eur. Ceram. Soc. 27 (2007) 4195 4198.
- [8] G. Amow, S.J. Skinner, Recent developments in Ruddlesden Popper nickelate systems for solid oxide fuel cell cathodes, J. Solid State Electrochem. 10 (2006) 538 546.
- [9] F. Mauvy, C. Lalanne, J.-M. Bassat, J.-C. Grenier, H. Zhao, L. Huo, Ph Stevens, Electrode properties of Ln2NiO4+ δ (Ln La, Nd, Pr) AC impedance and DC polarization studies, J. Electrochem. Soc. 153 (2006) A1547 A1553.
- [10] V.V. Kharton, A.P. Viskup, A.V. Kovalevsky, E.N. Naumovich, F.M.B. Marques, Ionic transport in oxygen-hyperstoichiometric phases with K 2 NiF 4-type structure, Solid State Ionics 143 (2001) 337 353.
- [11] J.A. Kilner, C.K.M. Shaw, Mass transport in La 2 Ni 1-x Co x O  $4+\delta$  oxides with the K2NiF4 structure, Solid State Ionics 154 155 (2002) 523 527.

- [12] F. Mauvy, J.M. Bassat, E. Boehm, P. Dordor, J.-P. Loup, F. Mauvy, J.M. Bassat, E. Boehm, P. Dordor, J.P. Loup, Measurement of chemical and tracer diffusion coefficients of oxygen in La 2 Cu 0.5 Ni 0.5 O 4+ δ, Solid State Ionics 158 (2003) (2003) 395 407.
- [13] F. Mauvy, J.-M. Bassat, E. Boehm, J.-P. Manaud, P. Dordor, J.-C. Grenier, Oxygen electrode reaction on Nd 2 NiO 4+ δ cathode materials: impedance spectroscopy study, Solid State Ionics 158 (2003) 17 28.
- [14] E. Boehm, J.-M. Bassat, P. Dordor, F. Mauvy, J.-C. Grenier, P. Stevens, Oxygen diffusion and transport properties in non-stoichiometric Ln 2- x NiO 4+ δ oxides, Solid State Ionics 176 (2005) 2717 2725.
- [15] D. Herbstritt, A. Weber, E. Ivers-Tiffée, Modelling and DC-polarisation of a three dimensional electrode/electrolyte interface, J. Eur. Ceram. Soc. 21 (2001) 1813 1816.
- [16] M. Al Daroukh, V.V. Vashook, H. Ullmann, F. Tietz, I. Arual Raj, Oxides of the AMO3 and A2MO4-type: structural stability, electrical conductivity and thermal expansion, Solid State Ionics 158 (2003) 141 150.
- [17] A. Demourgues, A. Wattiaux, J.C. Grenier, M. Pouchard, J.L. Soubeyroux, J.M. Dance, P. Hagenmuller, A. Demourgues, A. Wattiaux, J.C. Grenier, M. Pouchard, J.L. Soubeyroux, J.M. Dance, P. Hagenmuller, Electrochemical preparation and structural characterization of La2NiO4+  $\delta$  phases (0 $\leq \delta \leq$  0.25), J. Solid State Chem. 105 (1993) (1993) 458–468.
- [18] A.A. Yaremchenko, V.V. Kharton, M.V. Patrakeev, J.R. Frade, p-Type electronic conductivity, oxygen permeability and stability of La 2 Ni 0.9 Co 0.1 O 4+  $\delta$ , J. Mater. Chem. 13 (2003) 1136–1144.
- [19] S. Molin, P.Z. Jasinski, Improved performance of LaNi 0.6 Fe 0.4 O 3 solid oxide fuel cell cathode by application of a thin interface cathode functional layer, Mater. Lett. 189 (2017) 252 255.
- [20] N. Hildenbrand, B.A. Boukamp, P. Nammensma, D.H. Blank, Improved cathode/electrolyte interface of SOFC, Solid State Ionics 192 (1) (2011) 12 15.
- [21] M. Benamira, M. Letilly, E. Quarez, O. Joubert, A.L.G. La Salle, Optimization of SOFC anode/electrolyte assembly based on Baln 0.3 Ti 0.7 O 2.85 (BIT07)/Ni-BIT07 using an interfacial anodic layer, J. Power Sources 251 (2014) 66 74.
- [22] M. Benamira, A. Ringuede, M. Cassir, D. Horwat, J.F. Pierson, P. Lenormand, J. Fullenwarth, Comparison between ultrathin films of YSZ deposited at the solid oxide fuel cell cathode/electrolyte interface by atomic layer deposition, dip-coating or sputtering, Open Fuel Energy Sci. J. 2 (1) (2009) 87 99.
- [23] A.P. Kulkarni, S. Giddey, S.P.S. Badwal, Enhancing oxygen reduction reactions in solid oxide fuel cells with ultrathin nanofilm electrode electrolyte interfacial layers, J. Phys. Chem. C 120 (29) (2016) 15675 15683.
- [24] P. Briois, F. Perry, A. Billard, Structural and electrical characterisation of lanthanum nickelate reactively sputter-deposited thin films, Thin Solid Films 516 (2008) 3282 3286.
- [25] M.P. Pechini, Patent 3,330,697, 11th July 1967.

- [26] M.L. Fontaine, C. Laberty-Robert, A. Barnabé, F. Ansart, P. Tailhades, Synthesis of La 2-x NiO  $4+\delta$  oxides by polymeric route: non-stoichiometry control, Ceram. Int. 30 (2004) 2087 2098.
- [27] C. Brahim, A. Ringuedé, E. Gourba, M. Cassir, A. Billard, P. Briois, Electrical properties of thin bilayered YSZ/GDC SOFC electrolyte elaborated by sputtering, J. Power Sources 156 (2006) (2006) 45–49.
- [28] B.A. Boukamp, A nonlinear least squares fit procedure for analysis of immittance data of electrochemical systems, Solid State Ionics 20 (1986) 31 44.
- [29] J. Wu, S.S. Pramana, S.J. Skinner, J.A. Kilner, A.P. Horsfield, Why Ni is absent from the surface of La 2 NiO 4+δ? J. Mater. Chem. 3 (47) (2015) 23760 23767.
- [30] A.M. Hernández, L. Mogni, A. Caneiro, La2NiO4+ δ as cathode for SOFC: reactivity study with YSZ and CGO electrolytes, International Journal of Hydrogen Energy 35 (11) (2010) 6031 6036.
- [31] N. Gauquelin, T.E. Weirich, M. Ceretti, W. Paulus, M. Schroeder, Long-term structural surface modifications of mixed conducting La 2 NiO 4+  $\delta$  at high temperatures, Monatsh. Chem. 140 (2009) 1095 1102.
- [32] R.K. Sharma, M. Burriel, L. Dessemond, J.M. Bassat, E. Djurado, Lan+ 1NinO3n+ 1 (n 2 and 3) phases and composites for solid oxide fuel cell cathodes: facile synthesis and electrochemical properties, J. Power Sources 325 (2016) 337 345.
- [33] Z. Lou, J. Peng, N. Dai, J. Qiao, Y. Yan, Z. Wang, K. Sun, High performance La3Ni2O7 cathode prepared by a facile sol gel method for intermediate temperature solid oxide fuel cells, Electrochem. Commun. 22 (2012) 97 100.
- [34] Z. Zhang, M. Greenblatt, J.B. Goodenough, Synthesis, structure, and properties of the layered perovskite La3Ni2O7-δ, J. Solid State Chem. 108 (2) (1994) 402 409.
- [35] F. Mauvy, C. Lalanne, J.-M. Bassat, J.-C. Grenier, H. Zhao, P. Dordor, Ph Stevens, Oxygen reduction on porous Ln2NiO4+δ electrodes, J. Eur. Ceram. Soc. 25 (2005) 2669 2672.
- [36] M.J. Escudero, A. Aguadero, J.A. Alonso, L. Daza, A kinetic study of oxygen reduction reaction on La2NiO4 cathodes by means of impedance spectroscopy, J. Electroanal. Chem. 611 (2007) 107 116.
- [37] E.J. Crumlin, E. Mutoro, S.J. Ahn, G.J. Ia O', D.N. Leonard, A. Borisevich, et al., Oxygen reduction kinetics enhancement on a heterostructured oxide surface for solid oxide fuel cells, J. Phys. Chem. Lett. 1 (21) (2010) 3149 3155.
- [38] R. Sayers, M. Rieu, P. Lenormand, F. Ansart, J.A. Kilner, S.J. Skinner, Development of lanthanum nickelate as a cathode for use in intermediate temperature solid oxide fuel cells, Solid State Ionics 192 (2011) 531 534.
- [39] H. Zhao, F. Mauvy, C. Lalanne, J.M. Bassat, S. Fourcade, J.C. Grenier, New cathode materials for ITSOFC: phase stability, oxygen exchange and cathode properties of La2– xNiO4+  $\delta$ , Solid State Ionics 179 (35 36) (2008) 2000 2005.